

IN THE UNITED STATES PATENT OFFICE

In re application of Hyman Kirtchik
Inv. No. 11,889
Application Serial No. -
Filed: Herewith
For: LOW REFLECTANCE INFRARED CAMOUFLAGE SYSTEM

GROUP
Examiner:

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

PRIOR ART STATEMENT UNDER 37 C.F.R. § 1.97

The applicant(s) wish to make of record the following prior art (with statement(s) of relevancy) which is/are believed to be the most relevant known to applicant(s) and/or the assignee concerning the invention as claimed in the above-identified application:

Prior Art Cited

3,614,188 [427-160-X]
3,619,235 [350-1.7-X]
3,682,528 [350-1.7]
3,733,217 [350-1.7-X]
3,816,271 [204-51]

Statement of Relevancy

Teaches use of germanium in infrared filters.
Teaches that infrared reflecting layer may consist of metallic oxides.
Teaches a plurality of layers as coating for countermeasure systems.
Background information relative to countermeasure for heat seeking missiles.
Background information relative to countermeasure for heat seeking missiles.

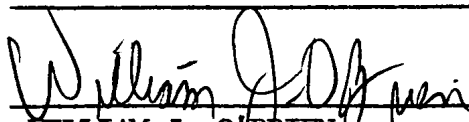
Copies of the above-identified prior art are enclosed herewith with copies of English translations of pertinent portions of any non-English language reference, if such translation was readily available.

The above cited prior art is not necessarily a complete listing of all prior art known to the applicant and/or the assignee. The listing only indicates that prior art which, in the reasonable opinion of the applicant and/or assignee, is the most relevant to the claimed invention.

Respectfully submitted,

24 July 1978

Date


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